

Purpose of this document



- The purpose of this paper is to perform automated measurements on a complete NASH2 wafer.
- ❖ We measure the following devices at DC.ON/DC.OFF→ DIE 01-01_DUT1/4

DIE 01-02_DUT1/2

DIE 01-03 DUT1/4

DIE 01-04_DUT1/2

DIE 01-05 DUT1/4

DIE 01-06_DUT1/4

DIE 01-07_DUT1/4

DIE 01-08 DUT1/4

DIE 01-09_DUT1/4

DIE 01-10 DUT1/4

DIE 01-11_DUT1/4



Summary



- I. Reticle map.
- II. Image of the reticle, die and device.
- III. Connections to be made.
- IV. Pull-in measurement at DC.ON/DC.OFF and script.
- V. Horizontal DICE and RETICULES dimensions & pitch.
- VI. Vertical DICE and RETICULES dimensions & pitch.
- VII. DICE pitch, dimensions & saw street details.
- VIII. PADS pitch.
- IX. Work to be done.



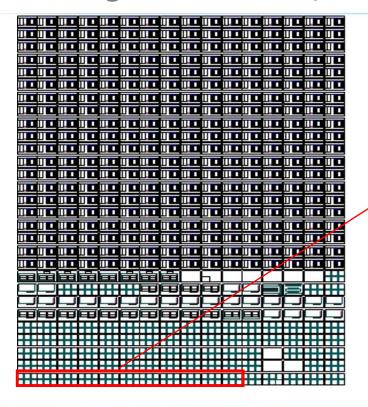
I. Reticle map

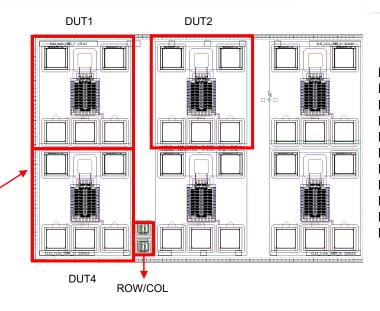


	1	2	3	4	
5	6	7	8	9	10
11	12	13	14	15	16
17	18	19	20	21	22
	23	24	25	26	



II. Image of the reticle, die and device.





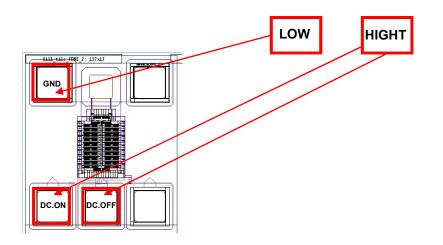
DIE 01-01_DUT1/4
DIE 01-02_DUT1/2
DIE 01-03_DUT1/4
DIE 01-04_DUT1/2
DIE 01-05_DUT1/4
DIE 01-06_DUT1/4
DIE 01-07_DUT1/4
DIE 01-08_DUT1/4
DIE 01-09_DUT1/4
DIE 01-10_DUT1/4
DIE 01-11_DUT1/4



III. Diagram of the connections and values of the sweep.



Impedance Analyzer



VALUES OF THE SWEEP

OscLevel=0.5

OscFreq=1e6

NumPoints=101

StartVolt=0

StopVolt=40

PrecisionAvg=5

PointAverage=0

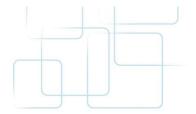
AveragePoints=8

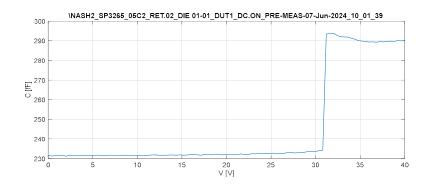
SweepAverage=0

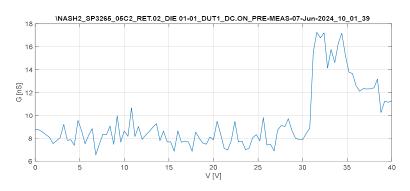
AverageSweeps=8



IV. Pull-in measurement at DC.ON and script



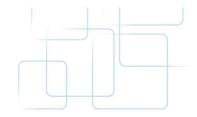




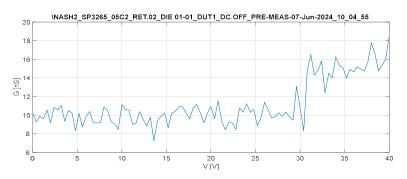
```
Measuring C,B using Keysight E4990A -- Agilent 4294A
Variables - Measurement
  clear;
  RunName = 'NASH2';
  IpAddress = '192.168.63.52';
  OscLevel = 0.5; % Volt, 5e-3 to 1, Resolution 1e-3
  OscFreq = le6; % Hz, 20 to 10e6, Resolution le-3
  NumPoints = 101; % Number of points per sweep, 2 to 1601
  StartVolt = 0; % Volt, -40 to +40, Resolution 1-3
  StopVolt = 40; % Volt, -40 to +40, Resolution 1-3
  PrecisionAvg = 5; % 1|2|3|4|5
  PointAverage = 0; % 0|1
  AveragePoints = 8; % 1 to 999
  SweepAverage = 0; % 0|1
  AverageSweeps = 8; % 1 to 999
  strPath = '';
```



IV. Pull-in measurement at DC.OFF and script







```
Measuring C,B using Keysight E4990A -- Agilent 4294A
Variables - Measurement
  clear;
  RunName = 'NASH2';
  IpAddress = '192.168.63.52';
  OscLevel = 0.5; % Volt, 5e-3 to 1, Resolution 1e-3
  OscFreq = le6; % Hz, 20 to 10e6, Resolution le-3
  NumPoints = 101; % Number of points per sweep, 2 to 1601
  StartVolt = 0; % Volt, -40 to +40, Resolution 1-3
  StopVolt = 40; % Volt, -40 to +40, Resolution 1-3
  PrecisionAvg = 5; % 1|2|3|4|5
  PointAverage = 0; % 0|1
  AveragePoints = 8; % 1 to 999
  SweepAverage = 0; % 0|1
  AverageSweeps = 8; % 1 to 999
  strPath = '';
```



V. Horizontal DICE and RETICULES dimensions & pitch

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Pitch between DICE is X= 1431um + 80um = 1511um

Y= 972um + 80um = 1052um

Y pitch Between Dice

• Pitch Between Reticules is X= 24096um + 960um = 25056um

Y= 30428um + 960um = 31388um

 Scribe lane width is 80um, for Nash2 SMIC added 880um spaces at the top and right of the GDS to place PCM TSK and alignment marks, combined the 80um street(scribe lane), total chip to chip space is should be 880+80=960um

Nash2	X (um)	Y (um)
A:Scribe Lane Width	960	960
B:Window size (including seal ring)	24096	30428
Reticle Pitch= A+B	25056	31388

Pitch X Between Reticles 25056 um	
X pitch Between Dice → 1511 um	Scribe Lane X Width: 960 um
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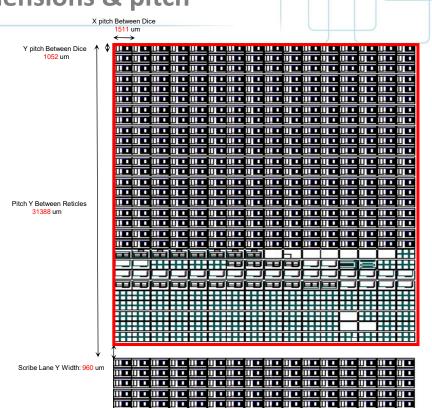
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VI. Vertical DICE and RETICULES dimensions & pitch

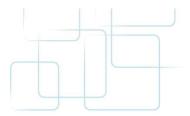
- Pitch Between DICE is X= 1431um + 80um = 1511um Y= 972um + 80um = 1052um
- Pitch Between Reticules is X= 24096um + 960um = 25056um Y= 30428um + 960um = 31388um
- Scribe lane width is 80um, for Nash2 SMIC added 880um spaces at the top and right of the GDS to place PCM TSK and alignment marks ,combined the 80um street(scribe lane) , total chip to chip space is should be 880+80=960um

Nash2	X (um)	Y (um)
A:Scribe Lane Width	960	960
B:Window size (including seal ring)	24096	30428
Reticle Pitch= A+B	25056	31388





VII .DICE pitch, dimensions & saw street details



Dicing Street:80um

Pitch between dice is X= 1511 um

Y= 1052 um

DIE size is X= 1431 um

Y= 972 um

• Dicing street width between dice: 80 um

Pitch Y Between Dice 1052 um

Y Dice size 972 um

Pitch X Between Dice 1431 um

Pitch X Between Dice 1431 um

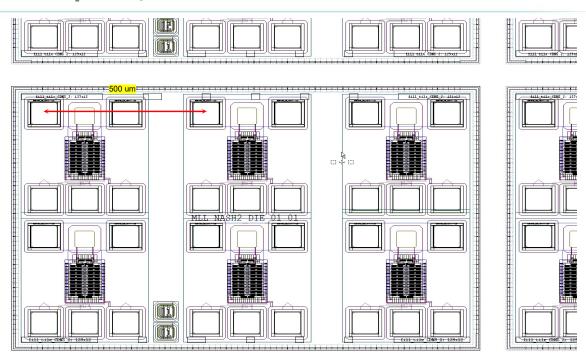
Pitch X Between Dice 1511 um

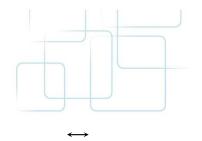
Pitch X Between Dice 1511 um

Pitch X Between Dice 1511 um



VIII .PADS pitch, dimensions & saw street details







IX. Work to be done

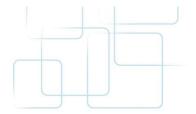


Perform DC.ON and DC.OFF measurements of the following devices on all wafer reticles:

- DIE 01-01_DUT1/4
- DIE 01-02_DUT1/2
- DIE 01-03_DUT1/4
- DIE 01-04_DUT1/2
- DIE 01-05_DUT1/4
- DIE 01-06_DUT1/4
- DIE 01-07_DUT1/4
- DIE 01-08_DUT1/4
- DIE 01-09_DUT1/4
- DIE 01-10_DUT1/4
- DIE 01-11_DUT1/4



Document Revisions



Revision	Author	Date	Comments
Rev 0.0	Lola Rodríguez	16/10/2024	Initial document



